

<b>Notice of References Cited</b>	Application/Control No. 10/655,221	Applicant(s)/Patent Under Reexamination LEE ET AL.	
	Examiner Mike Qi	Art Unit 2871	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,650,390 B2	11-2003	Sakamoto et al.	349/143
	B	US-6,822,723 B2	11-2004	Song et al.	349/178
	C	US-6,583,837 B1	06-2003	Fukumoto et al.	349/129
	D	US-5,263,888	11-1993	Ishihara et al.	445/25
	E	US-6,654,084 B1	11-2003	Marukawa et al.	349/110
	F	US-6,657,695 B1	12-2003	Song et al.	349/143
	G	US-6,710,837 B1	03-2004	Song et al.	349/143
	H	US-2001/0007487 A1	07-2001	Yoon et al.	349/106
	I	US-6,219,126 B1	04-2001	Von Gutfeld	349/153
	J	US-6,636,290 B1	10-2003	Glownia et al	349/187
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.